

	Subclass
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PATENT NUMBER:

U.S. UTILITY Patent Application

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PATENT DATE

APPLICATION NO. 097767659	CONT/PRIOR D	CLASS 400 414	SUBCLASS 217	ART UNIT 2012 763	EXAMINER FOX
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APPLICANTS
Richard Savage
Frank Menagh
Helder Garvalheria
Philip Troiani

TITLE
Semiconductor wafer processing system with vertically stacked process chambers and single-axis dual-wafer transfer system

PTO-2040
12/06

ISSUING CLASSIFICATION

[illegible]

<input type="checkbox"/> TERMINAL DISCLAIMER	DRAWINGS		CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims
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